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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: William J. Schaff et al.

Title: AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD OF FORMING AN AIN COATING

Docket No.: 1153.044US1

Serial No.: 09/858,337

Filed: May 15, 2001

Due Date: September 6, 2005

Examiner: Khanh B. Duong

Group Art Unit: 2822

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450


We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ Return postcard.
- ☒ Notice of Appeal (1 pg.).
- ☒ Petition for Extension of Time (1 pg.)
- ☒ Authorization to charge to Deposit Account No. 19-0743 in the amount of \$450.00 to cover the Extension of Time Fee.
- ☒ Authorization to charge to Deposit Account No. 19-0743 in the amount of \$250.00 to cover the Notice of Appeal fee.


If not provided for in a separate paper filed herewith, Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

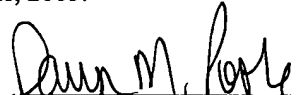
SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

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CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 23rd day of November, 2005.


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(GENERAL)